Docket No.: 2013P130

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

CHANGSOO KWAK, ET AL.

Art Group:

Application No.:

Examiner:

Filed:

For: APPARATUS FOR MEASURING GAP BETWEEN MASK AND SUBSTRATE USING LASER DISPLACEMENT SENSOR, AND METHOD THEREOF

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure, enclosed is a copy of Information Disclosure Statement by Applicant (form PTO/SB/08), which is being submitted concurrently with the Utility Application. It is respectfully requested that the cited references be considered and that the enclosed copy of PTO/SB/08 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s).

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The submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made in the subject application and is not to be construed as an admission that the information cited in this statement is material to patentability.

Please charge any fees due to Deposit Account 02-2666. A duplicate copy of the Fee Transmittal (PTO/SB/17) is enclosed for this purpose.

Date: ______ [1(15/03

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

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Los Angeles, CA 90025 Telephone: (310) 207-3800

Substitute for form 1449A/PTO				Complete if Known		
			CUDE	Application Number		
INFORMATION DISCLOSURE				Filing Date		
STATEMENT BY APPLICANT (use as many sheets as necessary)				First Named Inventor	Changsoo KWAK	
				Art Unit		
(use as many sheets us necessary)			u. ,,	Examiner Name		
Sheet	1	of	1	Attorney Docket Number	2013P130	

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U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number Number - Kind Code ² (if known)	Publication Date or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		US-5,239,183	08-24-1993	Kouno et al.		
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	FOREIGN PATENT DOCUMENTS						
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Initials*	No.1	Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	ް	

Examiner Date	
Signature Consideration Consid	red

Based on PTO/SB/08A (08-03) as modified by Blakely, Solokoff, Taylor & Zafman (wlr) 08/11/2003.

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.